



INTERNATIONAL  
GEMOLOGICAL  
INSTITUTE

## ELECTRONIC COPY

### LABORATORY GROWN DIAMOND REPORT

November 24, 2025

IGI Report Number **LG747572411**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **CUT CORNERED RECTANGULAR MODIFIED BRILLIANT**

Measurements **9.06 X 6.10 X 4.25 MM**

#### GRADING RESULTS

Carat Weight **2.06 CARATS**

Color Grade **D**

Clarity Grade **VVS 2**

#### ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

Symmetry **EXCELLENT**

Fluorescence **NONE**

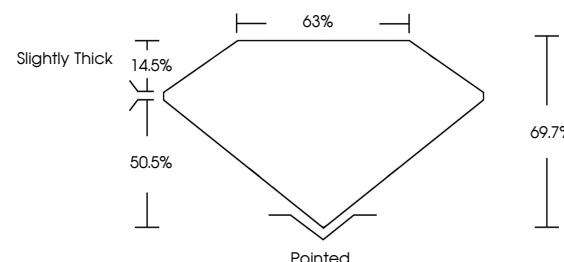
Inscription(s) **IGI LG747572411**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

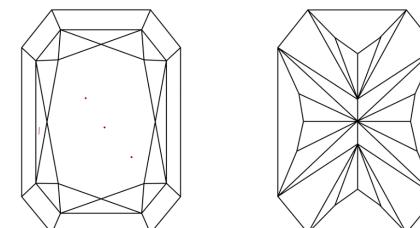
Type IIa

LG747572411  
Report verification at [igi.org](http://igi.org)

#### PROPORTIONS



#### CLARITY CHARACTERISTICS



#### KEY TO SYMBOLS

Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

[www.igi.org](http://www.igi.org)

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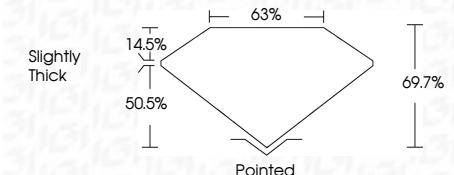
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November 24, 2025	IGI Report No LG747572411	CUT CORNERED RECT. MODIFIED BRILLIANT	Carat Weight 2.06 CARATS	Color Grade D	Clarity Grade VVS 2	Depth 69.7%	Table 63%	Girdle Slightly Thick	Culet Pointed	Polish EXCELLENT	Symmetry EXCELLENT	Fluorescence NONE	Inscription(s) LG747572411
			9.06 X 6.10 X 4.25 MM	50.5%	63%	69.7%	14.5%	Pointed	EXCELLENT	EXCELLENT	NONE		

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Type IIa